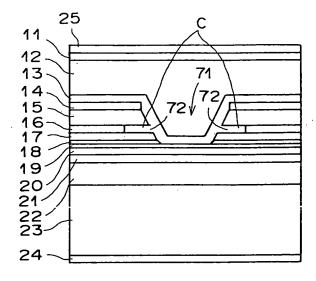
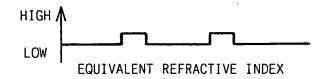
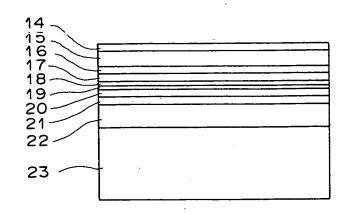
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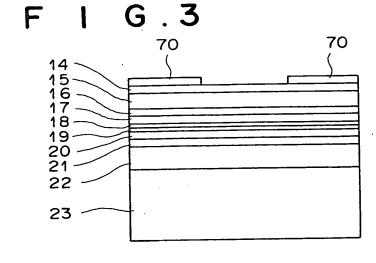


F I G.1B

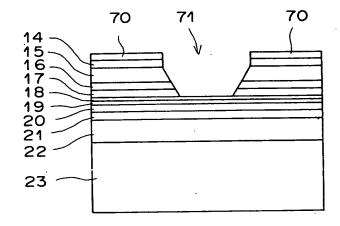


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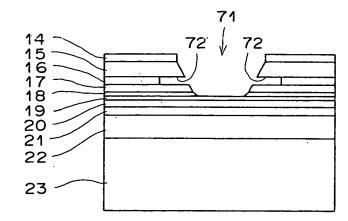


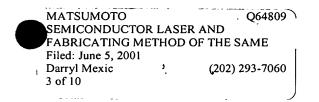


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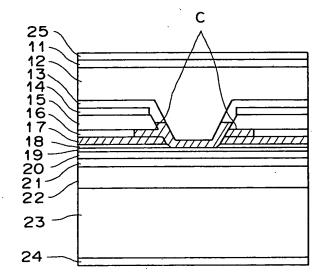


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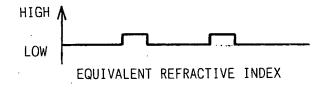




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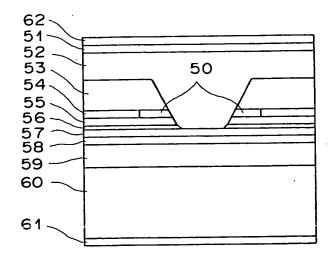


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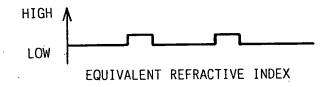


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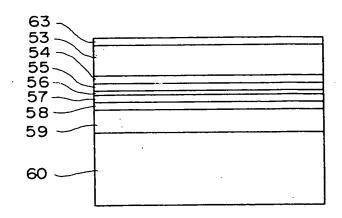
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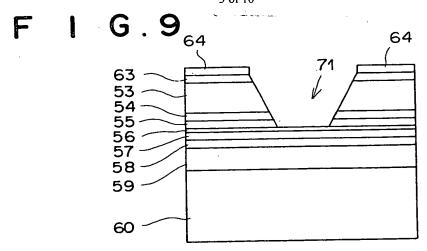
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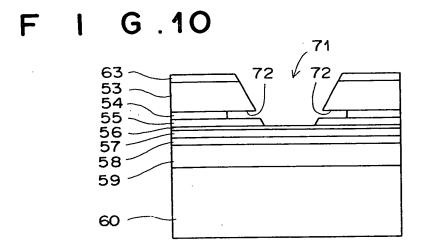


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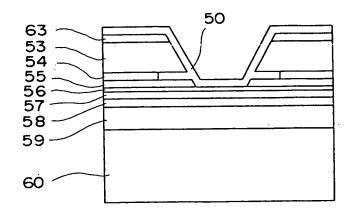


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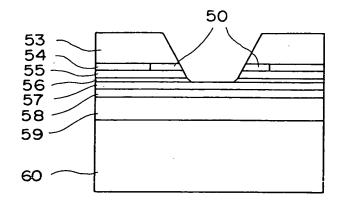




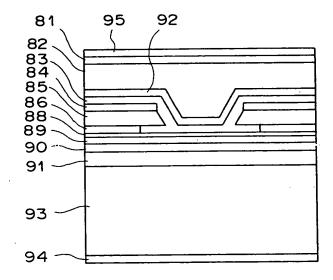
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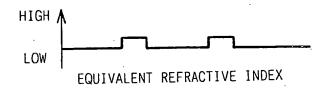
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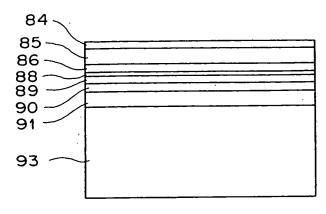


F I G: 13B

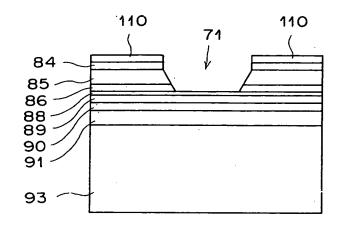


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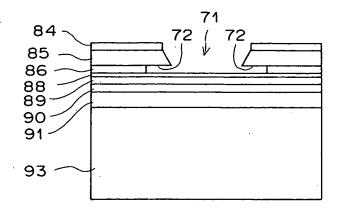
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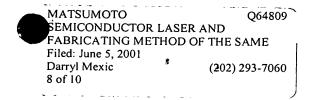


F I G.15

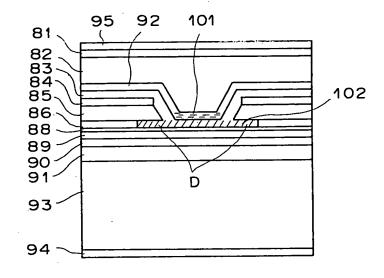


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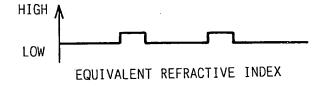




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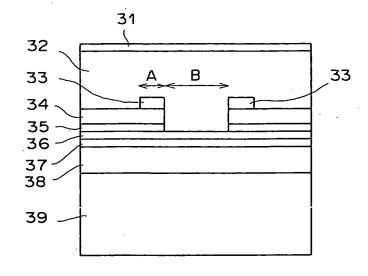


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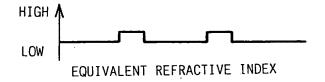


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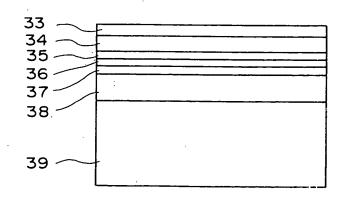
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F I G.18B



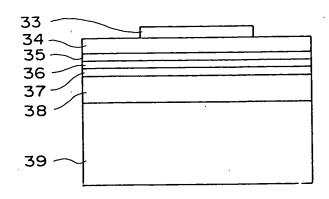
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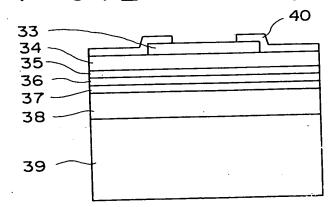


Hart Con the Cont took of the

F I G.20



F I G.21



F I G.22

